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Applicant:

Jaiswal

Docket No: TI-34403.1

Serial No:

10/679,783

Examiner:

McDonald, Rodney Glenn

Filed:

10/6/2003

Art Unit:

1753

For:

CONTROL OF NICHROME RESISTOR TEMPERATURE COEFFICIENT USING RF

PLASMA SPUTTER ETCH

EXTENSION OF TIME

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Assistant Commissioner For Patents Washington, DC 20231

CERTIFICATION OF FACSIMILE TRAN	ISMISSIO	N
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I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark

Office at 571-273-8300 on

Dear Sir:

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petition(s) the Commissioner for an extension of the shortened statutory period for response in the above identified Application.

The fee for this extension is indicated below:

X One Month (\$120)

Three Months (\$1020)

Two Months (\$450)

Four Months (\$1590)

Any further necessary extension of time is hereby requested. Charge any and all fees, or credit any overpayment, to the deposit account of Texas Instruments Incorporated, Account No. 20-0668.

Respectfully submitted.

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Texas Instruments Incorporated P.O. Box 655474, MS 3999 Dallas, TX 75265 (972) 917-5633

W. Daniel Swayze, Jr. Attorney for Applicant Reg. No. 34,478